



10/032,930
AMENDMENT IN RESPONSE TO
(OFFICE ACTION DATED JANUARY 24, 2003)

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Heikyung Min et al.

Appln. No.: 10/032,930

Filed: October 29, 2001

For: SEMICONDUCTOR STRUCTURE FOR
REDUCING SURFACE ZENER DRIFT
USING TITANIUM-BASED METALLURGY
(as amended)

Group Art Unit: 2818

Examiner: Dung A. Le

AMENDMENT (IN RESPONSE TO OFFICE
ACTION DATED JANUARY 24, 2003)

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Commissioner for Patents
Washington, D.C. 20231

Dear Sir:

In response to the Official Action mailed January 24, 2003, please amend the
above-identified application as follows:

In the Title

Please amend the title in all instances to read as follows:

**SEMICONDUCTOR STRUCTURE FOR REDUCING SURFACE ZENER DRIFT
USING TITANIUM-BASED METALLURGY**

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the
United States Postal Service, postage prepaid, in an envelope,
addressed to Box Non-Fee And, Commissioner for Patents,
Washington D.C. 20231-9999 on March 24, 2003

Dated: 03-24-03

By: [Signature]